

Michael J. Wise is a litigator well versed in representing public and private companies, nonprofit organizations and governmental entities in a broad spectrum of complex commercial cases, including mass torts, class action defense, premises liability claims, construction disputes, general liability defense, trusts and estates disputes, and bond and indemnity claims. Though his practice spans a diverse range of industries, Michael brings a tailored and practical approach to each case to help clients navigate disputes from inception to resolution before state and federal courts, arbitral forums and regulatory agencies. Michael is also a member of the firm's e-discovery team, helping develop cost-effective strategies for the preservation, collection, analysis and production of electronically stored information.

Michael graduated cum laude from Rutgers Law School-Camden, where he was staff editor for the *Rutgers University Law Review*. After law school, Michael completed judicial clerkships in the New Jersey Superior Court with Judge Richard Wells in the Law Division, Camden Vicinage, and with Judge William Nugent in the Appellate Division.

Prior to becoming a lawyer, Michael served as an infantry sergeant in the New Jersey Army National Guard and completed a yearlong deployment in support of Operation Enduring Freedom.

RECOGNITIONS

Pennsylvania Super Lawyers, Rising Star

FOCUS

Litigation

Complex Commercial & Class Action Litigation

Product Liability & Mass Tort Defense

Nonprofit & Religious Organizations Litigation

Construction

Appellate

E-Discovery Team

BAR ADMISSIONS

Pennsylvania

New Jersey

COURT ADMISSIONS

U.S. District Court for the Eastern District of Pennsylvania

U.S. District Court for the Middle District of Pennsylvania

U.S. District Court for the District of New Jersey

EDUCATION

J.D., cum laude, Rutgers University School of Law – Camden B.S., The College of New Jersey

MEMBERSHIPS

Pennsylvania Bar Association
New Jersey Bar Association
Camden County Bar Association
Stradley Ronon Technology Committee

